



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Robert J. Small and Zhefei Chen  
Title: Composition for Chemical-Mechanical Polishing and Method of Using Same  
Application No.: 10/619,901 Filing Date: July 14, 2003  
Examiner: Unknown Group Art Unit: 1711  
Docket No.: CHEM.006US0 Conf. No.: 7708

Certificate of Mailing Under 37 CFR 1.8

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Signature *Eileen Bower*

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**PETITION FOR EXTENSION OF TIME**

Dear Sir:

A one-month extension of time within which to respond to the May 12, 2004 outstanding Notice to File Missing Parts of Nonprovisional Application is hereby requested, such extension allowing the undersigned until August 12, 2004 to respond.

A check is enclosed that includes the amount of \$110.00, as set forth in the enclosed transmittal letter.

Respectfully submitted,

*K. Alison de Runtz*

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